



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q80781

Takeyoshi KANO, et al.

Appln. No.: 10/828,472

Group Art Unit: 1774

Confirmation No.: 5352

Examiner: Tamra Dicus

Filed: April 21, 2004

For: PATTERN FORMING METHOD, IMAGE FORMING METHOD, FINE PARTICLE
ADSORPTION PATTERN FORMING METHOD, CONDUCTIVE PATTERN FORMING
METHOD, PATTERN FORMING MATERIAL AND PLANOGRAPHIC PRINTING PLATE

LETTER OF CLARIFICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

On review of the Information Disclosure Statement and PTO/SB/08 A& B (modified) filed September 14, 2005, it is noted that "JP 59-101657" is listed on page 2 of the Information Disclosure Statement and on page 2 of the PTO/SB/08 A& B (modified) in error. Applicants apologize for the error and respectfully request that the Examiner disregard this entry.

Respectfully submitted,

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Date: November 20, 2006